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Attorney Docket No. 0149-053929

**10/564015**  
Customer No. 28289

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : Not Yet Assigned  
Applicant : **Shinji SHIMOSAKI et al.**  
Filed : Concurrently Herewith  
Title : **METHOD FOR FORMING METAL OXIDE  
COATING FILM AND VAPOR DEPOSITION  
APPARATUS**  
International Application No. : PCT/JP2004/009903  
International Filing Date : 06 July 2004  
Priority Date(s) Claimed : 10 July 2003

MAIL STOP PCT  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Prior to initial examination, please amend the above-identified patent application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 5 of this paper.

**Remarks** begin on page 8 of this paper.